

Electronic Acknowledgement Receipt

EFS ID:	1439199
Application Number:	10632873
International Application Number:	
Confirmation Number:	4644
Title of Invention:	Selective etching of carbon-doped low-k dielectrics
First Named Inventor/Applicant Name:	Yunsang Kim
Customer Number:	55649
Filer:	Alan Michael Taboada
Filer Authorized By:	
Attorney Docket Number:	APPM7354
Receipt Date:	15-JAN-2007
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Application Type:	Utility

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1		7354-RFOA.pdf	95929	yes	7

	Multipart Description/PDF files in .zip description		
	Document Description	Start	End
	Amendment After Final	1	1
	Claims	2	5
	Applicant Arguments/Remarks Made in an Amendment	6	7

Warnings:

Information:

Total Files Size (in bytes):	95929
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.